Development of Three-Dimensional SPEM at SPring-8 BL07LSU

<u>Koji Horiba</u>^{1,2,3}, Satoshi Toyoda¹, Naoka Nagamura¹, Hiroshi Kumigashira^{1,2,4}, Masaharu Oshima^{1,2,3}, Kenta Amemiya^{3,5}, Yasunori Senba⁶, and Haruhiko Ohashi⁶

¹Graduate School of Engineering, The University of Tokyo, Tokyo 113-8656, JAPAN
²Synchrotron Radiation Research Organization, The University of Tokyo, Tokyo 113-8656, JAPAN
³Core Research for Evolutional Science and Technology, Japan Science and Technology Agency (JST-CREST), Tokyo 102-0075, JAPAN
⁴Precursory Research for Embryonic Science and Technology, Japan Science and Technology Agency (JST-PRESTO), Kawaguchi 332-0012, Japan
⁵Photon Factory, Institute of Materials Structure Science, High Energy Accelerator Research Organization (KEK-PF), Tsukuba, 305-0801, JAPAN
⁶JASRI / SPring-8, Hyogo 679-5168, JAPAN

In order to achieve nondestructive observation of three-dimensional spatially resolved electronic structure in solids, we develop a new scanning photoelectron microscope system combined with depth profiling in electron spectroscopy for chemical analysis (ESCA). We call this system "3D nano-ESCA". For the x-ray focusing optics, a Frensnel zone plate (FZP) is used. The diameter and the outermost zone width of FZP are 200 microns and 35 nanometers, respectively. In order to obtain angular dependence of photoelectron spectra without any sample rotating motion for depth profiling analysis using the maximum entropy method, we select a VG- Scienta R3000 analyzer with an acceptance angle of 60 degrees as a high-resolution angle-resolved electron spectrometer. The system has been installed at a new University of Tokyo Materials Science Outstation beamline BL07LSU of SPring-8. From the results of edge-scan profiles of a gold mesh, we have achieved the total spatial resolution of 92 nm.